

<b>Notice of References Cited</b>	Application/Control No. 10/671,143	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Rodney G. McDonald	Art Unit 1753	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,815,877	11-2004	Chen, Ga-Lane	313/311
*	B	US-RE38,561	08-2004	Keesmann et al.	313/309
*	C	US-2004/0067602	04-2004	Jin, Sungho	438/022
*	D	US-6,339,281	01-2002	Lee et al.	313/309
*	E	US-5,620,350	04-1997	Takemura, Hisashi	445/50
*	F	US-5,451,830	09-1995	Huang, Jammy C.	313/309
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bower et al. "Plasma-induced alignment of carbon nanotubes", Applied Physics Letters, Volume 77, Number 6, August 2000, pp. 830-832.
	✓	Zhang et al. "Electric-field Directed growth of aligned single-walled carbon nanotubes", Applied Physics Letters, Volume 79, Number 19, November 2001, pp. 3155-3157.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.